

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Raaijmakers et al.	)	Group Art Unit Unknown
			)	
Appl. No.	:	Unknown	)	
			)	
Filed	:	Herewith	)	
			)	
For	:	METHOD OF DEPOSITING	)	
		SILICON WITH HIGH STEP	)	
		COVERAGE	)	
			)	
Examiner	:	Unknown	)	

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Prior to examination on the merits, please amend the above-captioned application as indicated below.

IN THE SPECIFICATION

On page 1, after the title, insert the following heading and paragraph:

*1086232106*  
--Reference to Related Applications

The present application is a divisional of U.S. Patent Application No. 09/264,167 filed March 5, 1999, which claims the priority benefit under 35 U.S.C. § 119(e) for provisional Application No. 60/077,082 filed March 6, 1998 --

IN THE CLAIMS

Please cancel Claims 1-32.